

DEC-14-05 16:50

FROM:BEUSSE BROWNLEE ET AL

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TO: FROM:

Examiner: Fazli Erdem  
Art Unit: 2826

James H. Beusse

COMPANY: U.S. Patent Office	DATE: December 14, 2005
FAX NUMBER: 571-273-8300 – Central Fax No.	TOTAL NO. OF PAGES INCLUDING COVER: 6
PHONE NUMBER: 1-866-217-9197	SENDER'S REFERENCE NUMBER: Bhowmik 12-146-1.075903-033
RE: 09/967,094	YOUR REFERENCE NUMBER:

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URGENT    FOR REVIEW    PLEASE COMMENT    PLEASE REPLY    PLEASE RECYCLE

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NOTES/COMMENTS:

## RESPONSE TO OFFICE ACTION

Please confirm receipt.

THANKS.

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390 NORTH ORANGE AVENUE, SUITE 2500, ORLANDO, FLORIDA 32801  
TELEPHONE: (407) 926-7700 FAX: 407-926-7720

Application No. 09/967,094

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

First Named Inventor: Siddhartha Bhowmik

Application No.: 09/967,094

Filed: 09/28/2001

Examiner: Fazli Erdem Art Unit: 2826

For: Barrier Layer For Interconnect Structures  
Of A Semiconductor Wafer and Method For  
Depositing The Barrier Layer

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450RESPONSE

This paper is in response to the Office Action, dated as mailed September 30, 2005 and having a response due date of December 30, 2005.

Please proceed to the following page.